→ PTOGENFAX

Form PTC	-1449	U.S. Departme And Trademark	ATTY. DOCKET NO. SERIAL NO. ITW 14417.70 10/7286						_		
INFO	RMA'	SUPPLEMI TION DISCL	FILING DATE	uismann et al.							
			U.S.	DAMENT	DOCUMENTS	<u> </u>	200	<u> </u>			
	REF	PATENT	DATE	NAME	DOCUMENTS		CLAS	s sub-	. 1	FILING	_
EXAM. INIT.	Ka.r	NUMBER	DATE.	Marie				CLAS		DATE	
CS		3,975,616	8/17/76	Siktberg	et al.						_
						_		+-	-+		_
	├ ─		-	<u> </u>		-		+-	\dashv		
	+	+	 	_		-		+		-	
	+										
									[_
		<u> </u>	<u></u>	L					L		
					T DOCUMENT						
	REF DOCUMENT NUMBER		DATE	COUNTRY	<i>,</i>		CLASS S		YES	RANSLATION TES NO	
INIT		NUMBER	 	 		┿			1 20.	- "	<u> </u>
		······									
			Ţ								_
			<u> </u>				يلـــــــــــــــــــــــــــــــــــــ				
ОТН	ER I	DOCUMENTS	(Includi	ng Auth	or, Title,	Da	ite,	Page	s, :	Etc.)
			•					-	_		
	-										_
				-							
	-				4	-					
EXAMIN	I Ier	/Clifford	Shaw/	DATE CONS	SIDERED 5/	26/	200	6			
EXAMIN throug this i	h ci	Initial if tation if no with next co	t in confo	rmance an	ormance with d not considering.	MPI	P 60	9. Dra nclude	w li cop	ne y of	

I hereby certify that this correspondence is, on the date shown below, being transmitted by facsimile to the Patent and Trademark Office (Fat No. 1571)-273-8300

*DN*F:\WP51\DOCS\ITW\14417.70\14417.701449ID38.wpd Monday, February 13, 2006 1:21PM

Sheet 1 of 1.

Form PTO-1449 U.S. Department of Commerce Patent And Trademark Office					ATTY.DOCKET NO. ITW 14417	SERIAL NO. 10/728629					
TNE	ים ר	ת אלוא	SUPPLEME		APPLICANT Huismann et al.						
INFORMATION DISCLOSURE CITATION						FILING DATE December	5, 20	03	GROUP -3-7-42 1725		
U.S. PATENT DOCUMENTS											
EXAM. INIT.		REF	PATENT NUMBER	DATE	NAME		CLA	CLASS SU		B- FILIN ASS DATE	
	\pm									<u> </u>	
	+									ļ	
				FODETO	ן אר סאייניאויז	DOCUMENTS	<u> </u>				
EXAM	RE	F	DOCUMENT	DATE	COUNTRY	DOCUMENTS	CLASS	SUB-	1 771	VANSLAT	TON
INIT	NUMBER			DATE	COONTRI		CLASS SU				NO
CS		_	DE4204661C1	6/1992							
CS	<u>L</u> .		DE4118208A1	E4118208A1 11/1991 Germany							
CS		4	SU1,743,752	6/30/92	Union of S	Soviet Union					
OTI	HEF	R D	OCUMENTS	I (Includi	ng Autho	or, Title,	Date,	Pag	jes,	Etc	·)
CS	CS Direct Control Of The Material Transfer: The Controlled Sho Circuiting (CSC) MIG Process, G. Huismann						Short				
				***							***************************************
	1										
EXAMINER /Clifford Shaw/ DATE CONSIDERED 5/26/2006											
EXAMINER: Initial if citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.											

CERTIFICATE OF MAILIEU/TRANSMISSION (37 CFR 1.8m)

I hereby certify that this correspondence is, on the date shown below, being transmitted by EFS to the Patent and Trademark Office

George R. Corrigan